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JJC
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In re Application of)
LIOU et al.)
Application No. 09/467,675) DECISION *SUA SPONTE*
Filed: December 21, 1999) WITHDRAWING HOLDING
For: Structure for ESD Protection with Single) OF ABANDONMENT
Crystal Silicon Sided Junction Diode)

This is a decision, *sua sponte*, withdrawing the holding of abandonment of the above-identified application.

A non-final Office action was mailed on August 13, 2001, setting a three-month shortened statutory period for response. In the apparent absence of a proper response, the application was held abandoned and a Notice of Abandonment was mailed on April 11, 2002.

Although no petition or request to withdraw the holding of abandonment in this application has been filed, the Notice of Abandonment is hereby vacated, the holding of abandonment withdrawn and the application restored to pending status in view of the fact that a response to the Office action was filed on January 11, 2002, with a certificate of mailing dated December 6, 2001, and has recently been associated with the application file.

The application file is being forwarded to the technical support staff for Technology Center 2800 for processing of the response filed on January 11, 2002.



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